Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/750,006	EBIHARA, MIKA
Examiner	Art Unit
Donghee Kang	2811

	SEAR	CHED	
Class	Subclass	Date	Examiner
257	34,349,37 7,399	3/30/2005	KANG

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
east uspto,uspgpub,epo,jpo,dew,ibmtdb	3/30/2005	KANG
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